To: Vendinello, Lynn[Vendinello.Lynn@epa.gov]
Cc: Blunck, Christopher[Blunck.Chris@epa.gov]; Scheifele, Hans[Scheifele.Hans@epa.gov]; Doa, Maria[Doa.Maria@epa.gov]; Wolf, Joel[Wolf.Joel@epa.gov]
From: Morris, Jeff
Sent: Sat 11/25/2017 7:49:24 PM
Subject: RE: Information requested by Michael Dourson on CCD Integer Facility Visit

Lynn,

Thanks very much. I will pass it along to Mike.

Jeff

From: Vendinello, Lynn
Sent: Tuesday, November 21, 2017 12:26 PM
To: Morris, Jeff <Morris.Jeff@epa.gov>
Cc: Blunck, Christopher <Blunck.Chris@epa.gov>; Scheifele, Hans <Scheifele.Hans@epa.gov>; Doa, Maria <Doa.Maria@epa.gov>; Wolf, Joel <Wolf.Joel@epa.gov>
Subject: Information requested by Michael Dourson on CCD Integer Facility Visit

Hi Jeff, Mr. Dourson requested additional information about an OPPT staff visit to a TCE degreasing facility that he read about in the bi-weekly report. We have provided this additional information in the attached one-pager. If you are OK with the write-up could you please pass it onto him. Thanks.

Lynn Vendinello

Deputy Director

Chemical Control Division

Office of Pollution Prevention and Toxics

US. EPA

202-566-0514